

Application No.	Applicant(s)	
09/592,009	LEE ET AL.	
Examiner	Art Unit	
Kim Huvnh	2182	

SEARCHED					
Class	Subclass	Date	Examiner		
710	5,36,48, 29,266	2/>/05	cq		
712	228	4	1		
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INTERFERENCE SEARCHED				
Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
EAST, PGPUG, USPTO, JPO, EPO, DERWENT, NPL, PLUS	2/3/06	Of	